## Decoupling between propagating acoustic waves and two-level systems in hydrogenated amorphous silicon

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Specific heat measurements of hydrogenated amorphous silicon prepared by hot-wire chemical vapor deposition show a large density of two-level systems at low temperature. Annealing at 200 °C, well below the growth temperature, does not significantly affect the already-low internal friction or the sound velocity, but irreversibly reduces the non-Debye specific heat by an order of magnitude at 2 K, indicating a large reduction in the density of two-level systems. Comparison of the specific heat with the internal friction suggests that the two-level systems are uncharacteristically decoupled from acoustic waves, both before and after annealing. Analysis yields an anomalously low value of the coupling constant, which increases upon annealing but still remains anomalously low. The results suggest that the coupling constant value is lowered by the presence of hydrogen.

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Amorphous solids show anomalous thermal, elastic, and dielectric properties at low temperatures. The observation of anomalous thermal properties, through thermal conductivity and specific heat measurements [1], led in 1972 to development of the standard tunneling model (STM) [2,3], in which atoms or groups of atoms tunnel between nearly degenerate configurations with a distribution of asymmetries  $\Delta$  that are separated by energy barriers on the order of tens of kelvins with a distribution of tunneling parameter  $\lambda$ , resulting in tunneling-induced states with splittings < 1 K. The simplest description of these configurations and the resulting states is as a two-level systems (TLSs). The STM was further developed during the following years, providing an explanation for various anomalous low-temperature properties [4–10]. The specific structures that enable the TLSs are generally not known, but have been proposed for some specific materials, such as silica [11]. Recently, we suggested that TLSs in hydrogenated amorphous silicon (a-Si:H) are primarily due to clustered atomic H in low-density regions [12].

The STM assumes that the asymmetry between states,  $\Delta$ , is small, and that the tunneling parameter  $\lambda$  is uniformly distributed over a range of values, which allows the TLS distribution function,  $P(\Delta,\lambda)$ , to be written as  $P(\Delta,\lambda)\approx \bar{P}$ , where  $\bar{P}$  is the TLS density. Under this assumption, the specific heat,  $C_P(T)$ , of an ensemble of TLSs has a linear term,  $c_1$ , associated with the TLS density,  $n_0$ , of the TLSs that equilibrate with the phonon bath on the time scale of the measurement by

$$C_P(T) = c_1 T = \frac{\pi^2}{6} \frac{k_B^2 N_A}{n_{at}} n_0 T,$$
 (1)

where  $n_{\rm at}$  is the total atomic density,  $k_B$  is Boltzmann's constant, and  $N_A$  is Avogadro's number. The specific-heat-derived TLS density  $n_0$  is proportional to the TLS density  $\bar{P}$  through a relationship first proposed by Black and Halperin [6] and Black [7], and later experimentally verified [13,14], which establishes

$$n_0 = \frac{1}{2}\bar{P}\ln\left(\frac{4t}{\tau_{\min}}\right),\tag{2}$$

where t is the measurement time ( $\approx 10$  ms for the nanocalorimetric system used in this paper at low T) [15] and  $\tau_{\min}$  is the TLS minimum relaxation time. At low temperatures, typically below 10 K, the main TLS relaxation mechanism is the one-phonon process, in which  $\tau_{\min}$  is minimized when the energy difference between two TLS states  $E = \sqrt{\Delta^2 + \Delta_0^2} = \Delta_0$ , where  $\Delta_0$  is the TLS tunnel splitting. This condition implies that the minimum relaxation time is achieved by symmetric TLSs ( $\Delta = 0$ ). In dielectric glasses, the main contribution to specific heat and mechanical loss comes from TLSs with energy splitting  $E = k_B T$ , and their minimum relaxation time is given by [16–18]

$$\tau_{\min} = \left(\frac{\gamma_{\ell}^2}{v_{\ell}^5} + 2\frac{\gamma_{\ell}^2}{v_{\ell}^5}\right)^{-1} \frac{\pi \rho \hbar^4}{k_B^3} T^{-3} = aT^{-3}, \quad (3)$$

where subscripts  $\ell$  and t denote the longitudinal or transverse wave polarization, respectively, which from now on and as a generalization are denoted by the subscript  $\alpha$ .  $\gamma_{\alpha}$  is the coupling constant between TLS and phonons,  $v_{\alpha}$  is the sound velocity,  $\rho$  is the mass density, and T is the system temperature. Typically,  $a \approx 10^{-8}$  s K<sup>3</sup> [16,19], and therefore  $\tau_{\min} \approx 1$  ns at 2 K. Note that because of the logarithmic time dependence in Eq. (2), the ratio  $n_0/\bar{P}$  depends only weakly on the measurement time t and on the TLS minimum relaxation time  $\tau_{\min}$ , such that  $n_0/\bar{P} \approx 10$  for essentially all experimentally realized measurements [20].

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The interaction between phonons and TLS at low temperature leads to energy loss, which may occur by resonant or relaxation mechanisms. At temperatures above  $\sim 10$  K, losses arise from thermal activation over the energy barriers separating the states. At the experimental temperatures and excitation frequencies  $\omega$  used in this paper, relaxation dominates over resonant mechanisms through TLSs with  $\omega \tau = 1$ . The interaction between a phonon and a TLS is given by the deformation potential,  $\gamma_{i,\alpha} = \partial \Delta_i/2\partial u_\alpha$ , where  $u_\alpha$  is the strain tensor.  $\gamma_{i,\alpha}$  thus depends on the specific TLS. In the limit assumed by the STM, a single value of the deformation potential is used for all TLSs, the coupling constant  $\gamma_\alpha$ . In that limit and in the relaxation regime (when  $\omega \tau_{\min} \ll 1$ ), the mechanical loss  $Q_\alpha^{-1}(T)$  is temperature independent, typically from 0.1 to 10 K [4], and is given by

$$Q_{0,\alpha}^{-1} = \frac{\pi}{2} \frac{\bar{P} \gamma_{\alpha}^{2}}{\rho v_{\alpha}^{2}}.$$
 (4)

Experimentally,  $\gamma_{\alpha}$  can be determined combining acoustic dispersion and attenuation measurements [21], or specific heat and acoustic measurements [22]. Mechanical loss,  $Q_{\alpha}^{-1}(T)$ , measurements report the imaginary part of the elastic constant, the so-called anelastic energy loss. In amorphous solids, other contributions to  $Q_{\alpha}^{-1}(T)$  are negligible in this temperature range. Surprisingly,  $Q_{0,\alpha}^{-1}$  ranges from  $10^{-4}$  to  $10^{-3}$  for most glasses and varies little with differing chemical compositions [23]. This "universal" glassy range is not a consequence of the STM and has been long considered one of the great mysteries of glasses. Relatively recent explanations of this effect center on the concept of self-interacting TLSs, which renormalize the TLS density and yield approximately the observed universal number [24,25].

The relative change with temperature of the sound velocity  $\Delta v_{\alpha}/v_{0,\alpha}$  reports the real part of the elastic constant and is measured from the relative variation of the resonant frequency of the oscillator with temperature,  $\Delta f/f_0$ , with  $f_0$  being the frequency at a reference temperature  $T_0$ . Elastic properties measurements have shown that the thermally activated relaxation rate of the TLS causes a reduction in  $\Delta v_{\alpha}/v_{0,\alpha}$  proportional to temperature,

$$\frac{\Delta v_{\alpha}}{v_{0,\alpha}} = -\beta_{\alpha}(T - T_0),\tag{5}$$

where  $v_{0,\alpha}$  is the sound velocity at an arbitrary reference temperature  $T_0$ . Equation (5) is not predicted by the STM, but an extension of this model considering thermally activated relaxation processes predicts the linear dependence of  $\Delta v_{\alpha}/v_{0,\alpha}$  with T [26]. Experimentally,  $\beta_{\alpha}$  has been found to be proportional to  $Q_{0,\alpha}^{-1}$  for a large number of systems, including amorphous solids, quasicrystals, and disordered crystals. Specifically, the average proportionality for all the studied systems yields  $\beta_t/Q_{0,t}^{-1}=0.5~\mathrm{K}^{-1}$  [27]. The results presented in this paper are obtained from transverse modes, so from now on, and unless noted, we always refer to transverse components and omit the wave polarization notation.

It has been shown that vapor-deposited films grown under specific conditions surpass constraints that limit the properties of glasses obtained from the liquid phase, producing ultrastable glasses, i.e., glasses with higher glass transition temperature and atomic density [28–30]. A correlation

between atomic density and TLS density, derived from both specific heat and mechanical loss (extending far below the "universal" glassy range), in a-Si films grown under conditions suggesting ultrastability has been shown [31–33]. a-Si:H was the first material for which  $Q_0^{-1}$  values below the "universal" glassy range were reported; such values were initially suggested to be due to the presence of hydrogen [34,35] but were subsequently found as well in a-Si (without H) grown at elevated temperature [32,33]. Recently, the TLS density of a-Si:H films grown under different conditions has been studied using specific heat,  $C_P(T)$ , measurements [12]. The aim of this work is to compare  $n_0$  and  $Q_0^{-1}$  measured on equivalent samples of a-Si:H in the as-prepared and annealed states, where it is known that annealing allows hydrogen to redistribute while preserving the silicon network [12], and thus obtain a better understanding of the STM.

We report measurements of specific heat  $C_P(T)$ , mechanical loss  $Q^{-1}(T)$ , longitudinal sound velocity  $v_{\ell}$ , and relative change of the sound velocity  $\Delta v/v_0$  on devicequality a-Si:H films prepared by hot-wire chemical vapor deposition (HWCVD), at a growth rate of 2 nm/s, and at a substrate temperature  $T_S = 370$  °C, yielding films with 7% atomic hydrogen (7 at. % H). This preparation yields devicequality material with low dangling bond density [36]. Growth, infrared spectroscopy, and time-domain thermoreflectance characterizations of similar HWCVD films were discussed elsewhere [36,37]. The total atomic density (Si + H atoms) was determined by Rutherford backscattering spectrometry, in combination with a KLA-Tencor Alpha-Step IQ profilometer used to measure the films' thickness (~85 nm). These data show that the total atomic density depends nonmonotonically on growth temperature and at. % H.  $v_{\ell}$  was measured at room temperature by a picosecond ultrasonic pump-probe technique [38], yielding 7.7 km/s. Oxygen resonant scattering was used to look for oxygen content, and none was detected (<1 at. %). Films were measured in their as-deposited state and then annealed in vacuum at 200 °C for 10<sup>4</sup> s and measured again. Hydrogen forward scattering was used to measure H content, and, in particular, it proved that annealing did not remove any hydrogen from the films. Nuclear magnetic resonance (NMR) measurements show that annealing causes H to disperse more uniformly, primarily remaining in isolated Si-H bonds and sometimes forming H<sub>2</sub> molecules [39,40]. Clustering of H<sub>2</sub> can occur and cause bubbles, but this was not observed in the present films under the annealing conditions used.

 $C_P(T)$  was measured, both before and after annealing, from 2 to 300 K using the small  $\Delta T$  relaxation method [15] and a microfabricated thin-film nanocalorimeter [41].  $Q^{-1}(T)$  and  $\Delta v/v_0$  measurements were made from 0.3 to 100 K using the antisymmetric torsional mode of a double paddle oscillator (DPO) at  $\omega = 2\pi \times 5431$  Hz [42]. We note that the interaction between the TLS and phonons is dominated by relaxation processes, for both  $C_P(T)$  and  $Q^{-1}(T)$ , in these experimental conditions. An extended set of specific heat measurements and their analysis are reported elsewhere [12], showing the effect of growth temperature, annealing, and H content on the total specific heat, atomic density, sound velocity, and TLS density  $n_0$  for a range of HWCVD a-Si:H thin films.

Specific heat data on this 7 at. % H sample are shown in Fig. 1. The sound velocity and hence the Debye specific

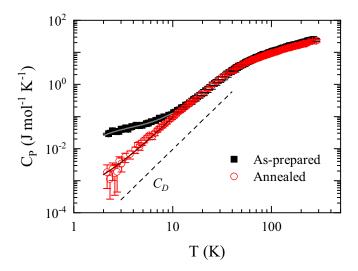


FIG. 1. Specific heat of a-Si:H film grown at  $T_S = 370$  °C (7 at. % H) in the as-prepared and annealed states. The Debye specific heat (dashed line),  $C_D = c_D T^3$ , is calculated from the measured sound velocity  $v_\ell$ . The solid gray and brown lines show the fitting to the as-prepared and annealed states, respectively, using Eq. (6).

heat,  $C_D$ , due to the phonon contribution did not change on annealing;  $C_D$  is shown with a dashed line.  $C_D$  was calculated from the measured atomic density and longitudinal sound velocities as  $C_D = (12\pi^4/5)N_Ak_B(T/T_D)^3$ , where  $T_D = (\hbar/k_B)\{6\pi^2n_{at}[1/(3v_l^3) + 2/(3v_l^3)]^{-1}\}^{1/3}$  is the Debye temperature. Transverse sound velocity was calculated using the relationship  $v_t = (0.56 \pm 0.05)v_\ell$ , established between longitudinal and transverse modes for amorphous materials [43], including our own work on a-Si [33].

The specific heat is significantly larger than the Debye specific heat, as is commonly found for amorphous materials. Data for the as-prepared and annealed states match above 10 K, making clear that vibrational modes are unchanged and the sample has not been modified by annealing, except for its H distribution and TLS parameters. Below 10 K, the values for the as-prepared sample are significantly larger than those of the annealed sample and show a sublinear temperature dependence, which must represent the high-temperature side of a peak in order to have nondivergent entropy as  $T \rightarrow 0$ . The simplest and most likely model for this peak is a Schottky anomaly [12].  $C_P(T)$  is therefore fit to the following form:

$$C_P(T) = C_{\text{Sch}}(T) + c_1 T + c_3 T^3,$$
 (6)

where  $C_{\rm Sch}(T)$  is the Schottky specific heat given by  $C_{\rm Sch}(T) = Nk_B (\frac{\Delta_0}{k_BT})^2 \frac{\exp{(\Delta_0/k_BT)}}{[1+\exp{(\Delta_0/k_BT)}]^2}$ , with N being the number of states with energy splitting  $\Delta_0$ ,  $c_1$  is given by Eq. (1), and  $c_3 = c_D + c_{ex}$ , with  $c_D$  being the Debye specific heat coefficient and  $c_{ex}$  being an excess cubic coefficient that is not predicted in the STM but has also been reported for a-Si thin films [31], and is discussed at length in Ref. [12], including a discussion of the form of this fit.

As discussed in Ref. [12], after annealing,  $C_P(T)$  below 10 K is significantly reduced but remains larger than  $c_D$  due to both  $c_1$  and  $c_{ex}$ , and, in particular, the Schottky term is gone. We note that the low-T  $C_P(T)$  of a-Si:H and a-Si does not depend on magnetic field, where we observed variations <1%

TABLE I. Sample state (as prepared or annealed at  $T_A = 200$  °C); Schottky specific heat  $C_{\rm Sch}$  at 2.4 K; TLS density  $n_0$  calculated from Eq. (1); slope of the relative change of the sound velocity with temperature,  $\beta$ , obtained from Eq. (5); and temperature-independent mechanical loss  $Q_0^{-1}$  at 1 K.

State	$C_{\rm Sch} \  imes 10^{-3} \ ({ m J mol}^{-1} \ { m K}^{-1})$	$n_0 \times 10^{46} $ (J <sup>-1</sup> m <sup>-3</sup> )	$\beta \times 10^{-6} \ (K^{-1})$	$Q_0^{-1} \times 10^{-5}$
As-prepared Annealed	$11.4 \pm 3.7$ 0	$209 \pm 26$ $29 \pm 3$		$1.07 \pm 0.02 \\ 1.15 \pm 0.02$

in fields up to 8 T (see Fig. 7.7 in Ref. [44]). These results confirm that electronic states are not responsible for the excess  $C_P(T)$  at low temperature.

The TLS density  $n_0$  is calculated from the data in Fig. 1 using Eq. (6) and is reported in Table I. The fits for  $n_0$  and  $c_{ex}$  are robust to details of the Schottky fit needed to explain the as-deposited data (e.g., multiple energy levels, varying N while fixing  $\Delta_0$ , degeneracy, etc.) as discussed in Ref. [12], which showed and discussed the specific heat of several samples grown at different temperatures and exhibiting different H content. We note here only that the lowest value of  $n_0$  is obtained from the sample reported in this paper ( $T_S = 370$  °C and 7 at. % H) both before and after annealing.

Mechanical loss,  $Q^{-1}(T)$ , of a-Si:H in the as-prepared and annealed states was measured using ring-down measurements of a DPO before and after deposition of the a-Si:H sample and also after annealing [42]. Results of  $Q^{-1}(T)$  are shown in Fig. 2, where  $Q_0^{-1}$  starts at 1 K.  $Q_0^{-1} \sim 1 \times 10^{-5}$  for the asdeposited state and increases  $\sim 8\%$  upon annealing. For other HWCVD a-Si:H,  $Q_0^{-1}$  has been found to range from  $4 \times 10^{-7}$  to  $2 \times 10^{-5}$  [45], consistent with our data; no explanation for this variation in  $Q_0^{-1}$  has yet been suggested. Figure 2 also

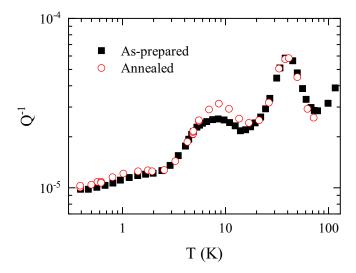


FIG. 2. Mechanical loss  $Q^{-1}$  as a function of temperature T for an a-Si:H film grown at  $T_S = 370\,^{\circ}\text{C}$  (7 at. % H) in its as-prepared (black solid squares) and annealed (red open circles) states. The loss difference between the bare DPO and the DPO with the film is of almost one order of magnitude, which ensures the accuracy of the measurement.

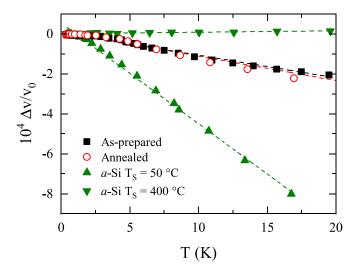


FIG. 3. Relative change of the sound velocity  $\Delta v/v_0$  as a function of temperature T of a-Si:H in both as-prepared (black solid squares) and annealed (red open circles) states. For comparison,  $\Delta v/v_0$  of a-Si samples grown at 50 °C (green upward-pointing triangles) and 400 °C (green downward-pointing triangles) are also shown from Ref. [32]. Dashed lines are linear fits showing  $\beta$  (see Table I).

shows two peaks: at 6 K (8 K after annealing) and 40 K. The peak near 6 K is likely due to H<sub>2</sub> in a nonbulk environment, caused by the liquid-solid transition of small clusters of H<sub>2</sub> in restricted geometries [46], including two-dimensional H<sub>2</sub> [47], which suppress the transition temperature. The lack of an  $H_2$  triple point signature in both  $C_P(T)$  and  $Q^{-1}(T)$  suggests the latter possibility, specifically, that H<sub>2</sub> clusters exist but are small enough that they do not behave as bulk H2. After annealing at 200 °C, the 6-K peak intensity is enhanced by almost 30% and becomes wider, which suggests an increase either in the H<sub>2</sub> content or in the ratio of clustered H<sub>2</sub> to isolated H<sub>2</sub>, consistent with literature on the effects of annealing below 200 °C [39,40]. The 40-K peak is not seen in any a-Si:H literature of which we are aware and is unchanged by annealing; it might be associated with contamination of some type.

Data on  $\Delta v/v_0$  for the *a*-Si:H sample are shown in Fig. 3. Again, little change is observed between the as-prepared and annealed states:  $\sim 7\%$  increase in  $\beta$ , consistent with the 8% increase seen above in  $Q_0^{-1}$ . We note the ratio between dispersion and attenuation properties  $\beta/Q_0^{-1}=1.1~{\rm K}^{-1}$ , which is more than two times the average experimental ratio of 0.5 K<sup>-1</sup> reported in previous works [27,45]. For comparison,  $\Delta v/v_0$  for *a*-Si is also shown in Fig. 3 for low and high growth temperatures [32], which yields high and low TLS density, respectively, and is quantitatively consistent with the data for *a*-Si:H.

To go further with the analysis, we calculate  $\bar{P}$  of a-Si:H from the specific heat values of  $n_0$  using Eq. (2), along with the experimental value of t=10 ms, and  $\tau_{\rm min}\approx 1.25$  ns, obtained from Eq. (3) with T=2 K, the lowest temperature of the specific heat measurements presented in this paper. This approach yields  $n_0/\bar{P}\approx 9$ ; therefore  $\bar{P}\approx 2.4\times 10^{47}~{\rm J^{-1}\,m^{-3}}$  before annealing, and  $\bar{P}\approx 3.4\times 10^{46}~{\rm J^{-1}m^{-3}}$  after. We note

again that the logarithm in Eq. (2) makes the choice of  $\tau_{\min}$  not important (three orders of magnitude change in  $\tau_{\min}$  modifies  $n_0/\bar{P}$  less than twofold).

The experimental values of  $Q_0^{-1}$  along with the values of  $\bar{P}$  calculated above, and combined in Eq. (4), yield  $\gamma=7$  and 19 meV for the as-prepared and annealed states, respectively. These results, however, lead to the nonintuitive conclusion that both  $\bar{P}$  and  $\gamma$  must change upon annealing in such a way that  $Q_0^{-1}$  barely changes. The usual approach of assuming a value for  $\gamma$ , e.g., 1 eV, leads to a value of  $\bar{P}$  from  $Q_0^{-1}$  that is orders of magnitude less than that found from  $C_P$  measurements, i.e., to a decoupling between propagating acoustic waves and TLSs, thus not explaining why the large  $\bar{P}$  found in heat capacity does not cause losses (an equivalent statement to the low  $\gamma$  derived on comparing the two measurements).

Very few studies have been made that estimate  $\gamma$ [22,43,48–51], which typically ranges from 0.1 to 1.5 eV, is considered a material constant, and has not been measured for a-Si:H. While the values of  $\gamma$  reported in this paper are unexpectedly low, there is nothing in the STM that prevents such low values. These low  $\gamma$  values are on the order of those reported in H-Nb systems [49,50], suggesting that H atoms might be responsible for the tunneling states in a-Si:H. The increased value of  $\gamma$ , obtained for the annealed state, and the fact that the sound velocity does not change, imply that upon annealing the minimum relaxation time decreases significantly (sevenfold) since  $\tau_{\rm min} \propto v^5/\gamma^2$  ([see Eq. (3)]. It is remarkable that  $Q_0^{-1}$  and  $\beta$ , both proportional to  $\bar{P}\gamma^2$ , increase very slightly after annealing, whereas  $n_0$  and thus P decrease noticeably. This apparent contradiction is mathematically solved if  $\gamma$  increases after annealing. We know that sound velocity does not change upon annealing, which suggests that the silicon structure is not altered. Additionally, the small increase in  $Q_0^{-1}$  and  $\Delta v/v_0$  may be caused by local structural changes when hydrogen diffuses. However, if the structural rearrangement of hydrogen atoms leads, as measured by  $C_P(T)$ , to a reduction in TLSs that turn out to be those with the lowest  $\gamma_i$  values, then  $\gamma$  should increase. This hypothesis explains why a reduction in  $\bar{P}$  upon annealing would correlate with an increase in  $\gamma$ , or vice versa, in a-Si:H.

Previous work has found that large variations in specific heat are often not associated with changes in thermal conductivity [52,53]. A similar inconsistency is found in  $C_P(T)$  and  $Q^{-1}(T)$  measurements of chemical-vapor-deposited amorphous silicon nitride, notably a material that contains of the order of 1–2 at. % H [54,55]. An alternative approach to the decoupling between specific heat and acoustic properties results was proposed by Black [7]; in this approach the samples may contain "anomalous" TLSs, besides "standard" TLSs. Black argued that anomalous TLSs relax fast enough to be measured by specific heat techniques but too slowly to be detected by acoustic properties techniques. In this approach, Black considered an additional TLS density for the anomalous states that would only contribute to the specific heat measurements. Despite the addition of anomalous TLSs, which to some extent improved the agreement between the STM and the experimental results, Black could not satisfactorily reconcile theory and results. We suggest that these apparent discrepancies are due to a misunderstanding of the coupling mechanisms between TLSs and propagating waves, i.e., the

deformation potential and, particularly, that it varies from TLS to TLS, and hence to the value of the coupling constant to be used within the STM. We *speculate* that if  $\gamma_i$  is not the same for all TLSs within the system, then the average value of such a distribution,  $\gamma$ , may depend on the relaxation times probed. We note that  $\tau$  ranges from  $\tau_{\min}$  to  $\sim 10$  ms for the  $C_P(T)$  results and  $\tau = 1/\omega \sim 30~\mu s$  for the  $Q^{-1}(T)$  results presented in this paper.

In conclusion, the TLS density measured by  $C_P(T)$  in HWCVD a-Si:H is significantly larger than that measured by  $Q^{-1}(T)$ . Furthermore, annealing promotes hydrogen redistribution while the silicon network is preserved, which leads to a reduction by an order of magnitude in the TLS density from  $C_P(T)$  while  $Q_0^{-1}$  and  $\beta$  slightly increase. The coupling constant of a-Si:H, derived from the STM prediction of  $n_0/\bar{P} \approx 10$ , yields  $\gamma = 7$  meV and increases to  $\gamma = 19$  meV after annealing, suggesting not only that  $\gamma$  is not a constant

material quantity but also that its value strongly depends on the microstructure. The low values of the coupling constant suggest that the TLSs that couple to applied elastic fields in a-Si:H are likely related to the presence of hydrogen within the amorphous silicon network. The discrepancy observed between  $C_P(T)$  and  $Q^{-1}(T)$  measurements shows that propagating acoustic waves are decoupled from TLSs with very low coupling constants.

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